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INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Confirmation Number		Unknown	
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				First Named Inventor		Henning SIRRINGHAUS	
				Art Unit		Unknown	
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Sheet 1 of 1				Attorney Docket Number		Q89250	

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ² (if known)		
		US 2002/119584	A1	08-29-2002	Gregg Duthaler, et al.
		US			
		US			
		US			
		US			
		US			

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)			
		WO	01/46987	A	06-28-2001	PLASTIC LOGIC LTD	

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶
		KAWASE, T. et al., "All-Polymer Thin Film Transistors Fabricated by Inkjet Printing", Proceedings of the SPIE, SPIE, Bellingham, VA, US Vol. 4466, July 29, 2001, Pages 80-88, XP008006102, ISSN: 0277-786X	
		CHABINYC MICHAEL L, et al., "Organic Polymeric Thin-film Transistors Fabricated by Selective Dewetting", Applied Physics Letters, American Institute of Physics, New York, US, Vol. 81, No. 22, November 25, 2002, 4260-4262, XP012032662, ISSN: 0003-6951	
		ZHANG, J. et al., Investigation of Using Contact and Non-contact Printing Technologies For Organic Transistor Fabrication, Material Research Society Symposium Proceedings, Materials Research Society, Pittsburgh, PA, US, Vol. 725, April 1, 2002, Pages 155-160, XP008020720, ISSN: 0272-9172	
		PEDE, D., et al., Microfabrication of Conducting Polymer Devices by Ink-jet Stereolithography", Materials Science and Engineering C, Elsevier Science S.A, CH, Vol. C05, No. 3/4, February 1998, pages 289-291, XP000828177, ISSN: 0928-4931	

Examiner Signature	/Tuan Nguyen/ (05/20/2008)	Date Considered
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